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#1-1/A PB 103
PATENT

Customer No. 22,852 Attorney Docket No. 03327.2252

TECHNOLOGY CENTER 3800 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takatoshi YAMASHITA) Group Art Unit: 2881
Application No.: 09/773,664) Examiner: M. El-Shammaa
Filed: February 2, 2001)
For: ION SOURCE AND OPERATION METHOD THEREOF)))
Commissioner for Patents Washington, DC 20231	

AMENDMENT

In response to the Office Action dated November 20, 2002, please reexamine and reconsider the application in view of the amendments and appended remarks.

IN THE SPECIFICATION:

Sir:

Please replace the paragraph that begins on line 1 of page 4 and ends on line 5 of page 4 with the following paragraph:

FINNEGAN HENDERSON FARABOW GARRETT& DUNNER LLP

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Fax 202.408.4400 www.finnegan.com As shown in FIG. 1, an ion beam 16 led out of the ion source contains a molecular ion (e.g., P_2^+ , As_2^+), which is an ion like a molecule, besides a monatomic ion (e.g., P^+ , As^+). The molecular ions include, for example, a diatomic ion composed of two atoms, and a triatomic ion composed of three atoms.